

Docket No.: 197802US2S

"RESPONSE UNDER 37 CFR 1.116-EXPEDITED PROCEDURE EXAMINING GROUP 2825

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313 Corres. and Mail

RE:

Application Serial No.: 09/670,520

Applicants: Wakako MORIYAMA, et al.

Filing Date: September 26, 2000

For: METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICES USING

THERMAL NITRIDE FILMS AS

GATE INSULATING FILMS

Group Art Unit: 2825

Examiner: LEE, G.

SIR:

Attached hereto for filing are the following papers:

Request for Reconsideration (After Final)

Our check in the amount of \$0.00 is attached covering any required fees. But the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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*RESPONSE UNDER 37 CFR 1.116-EXPEDITED PROCEDURE EXAMINING

GROUP 2825

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

RE APPLICATION OF

QCKET NO: 197802US2S

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: EXAMINER: LEE, G.

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FILMS

REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

This communication is in response to the Office Action dated August 13, 2003.